

**REQUEST FOR CONTINUED EXAMINATION
UNDER 37 CFR 1.114**

Applicant : Minoru Umemoto et al.

App. No. : 10/585,707

Filed : July 10, 2006

For : PROCESS OF FORMING ULTRAFINE CRYSTAL LAYER, MACHINE
COMPONENT HAVING ULTRAFINE CRYSTAL LAYER FORMED BY THE ULTRAFINE
CRYSTAL LAYER FORMING PROCESS...

Examiner : Christopher S. Kessler

Art Unit : 1793

**Commissioner for Patents
Alexandria, VA 22313-1450**

This is a request for continued examination under 37 CFR 1.114 in the above-identified utility patent application.

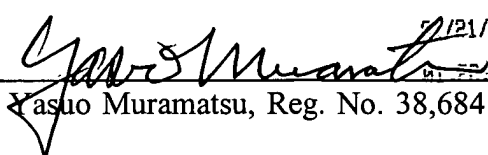
Enclosed:

- (X) Please enter the amendment submitted concurrently herewith in response to the office action dated July 9, 2010 and replace with the amendment dated October 11, 2010. The amendment is a bona fide attempt to advance the application.
- (X) A check in the amount of \$810.00 for RCE fee.
- (X) Return prepaid postcard.

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 10, 2011

(Date)


Yasuo Muramatsu, Reg. No. 38,684

Muramatsu & Associates
114 Pacifica, Suite 310
Irvine, CA 92618
(949) 753-1127